

Highlights from 10 years of CLICdp pixel-detector R&D

Mathieu Benoit

on behalf of all the collaborators over the years



BROOKHAVEN
NATIONAL LABORATORY



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Outline

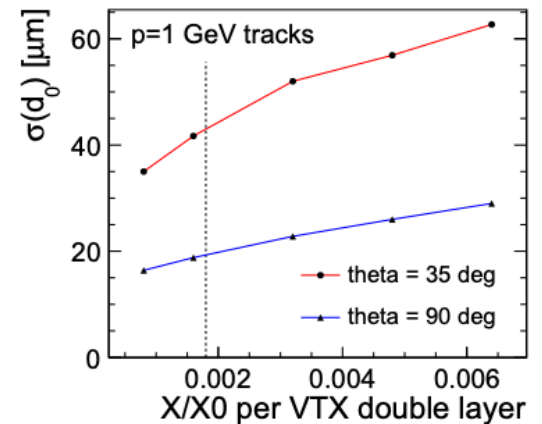
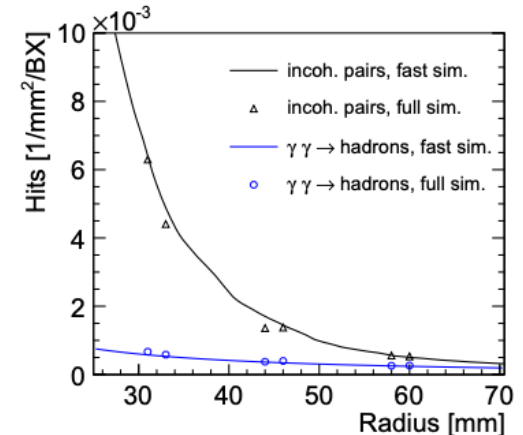
- Early years
 - Conceptual Design Report studies
 - First experimentation with Timepix
- Towards a detector model
 - Cooling simulation
 - Powering and power pulsing
 - Petals and whirlwinds !
- First prototypes : Towards thin pixel sensors
 - Timepix prototypes with thin sensors
 - The CLICpix ASIC
 - Simulation studies

Outline

- Pixel detectors : The next generation
 - Active-edge prototypes with Timepix3
 - First CLICPix prototypes
 - TSV studies
 - CLICpix2
- Developing tools
 - Allpix²
 - CaRIBOu, peary
 - The Timepix3 Telescope
- Beyond bump bonding
 - CCPD prototyping
 - Monolithic sensors : SOIPix, ATLASpix and CLICTD

Early years : The Conceptual Design Report

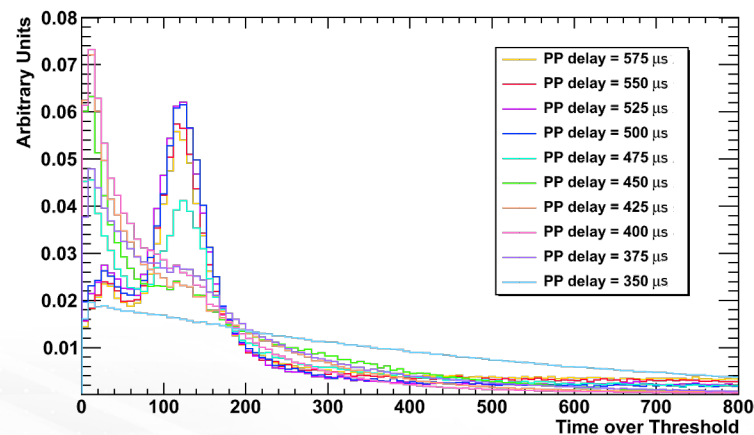
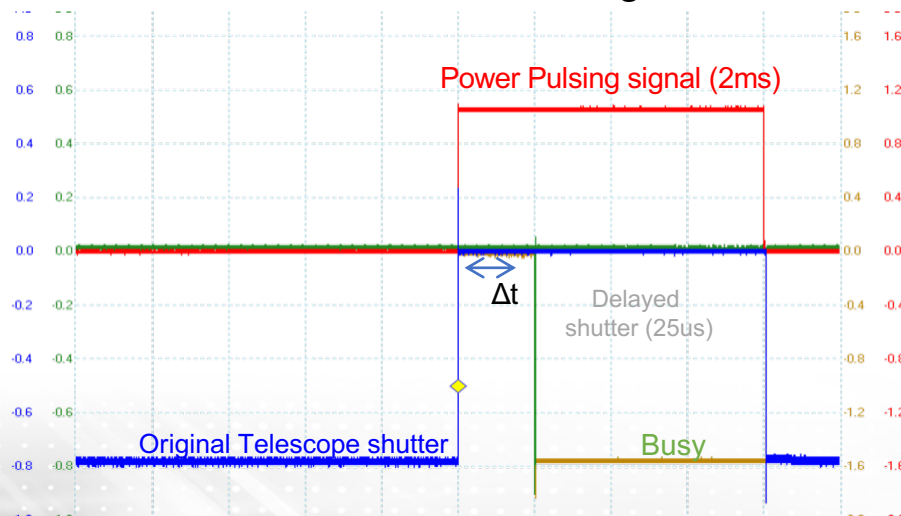
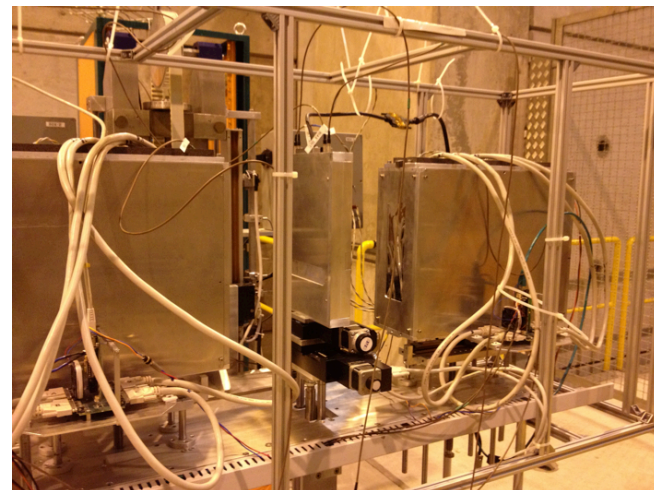
- Elaborated in 2010-2011, the [CLIC Detector and Physics Conceptual Design Report](#) set the course for the CLIC Vertex and Tracker detector R&D
 - The primary technological challenges to be addressed are in the **power delivery, readout, interconnect, and low-mass mechanical construction**.
 - **Sensor thinning** and **ultra low-mass material construction** will be necessary to stay within the material budget constraints implied by the physics goals outlined
 - **Interconnect technologies and pixel connectivity** must be studied and optimised.
 - we note the ongoing R&D on **CMOS MAPS technologies**, where several approaches are being pursued
 - The need for timing information implies a high-resistivity sensitive medium and full depletion, with advanced readout functionality for the individual pixels in the array. (...) one can think of **several developmental roadmaps** that can lead to a pixel detector technology for CLIC.



(b) Material in barrel pixel layers

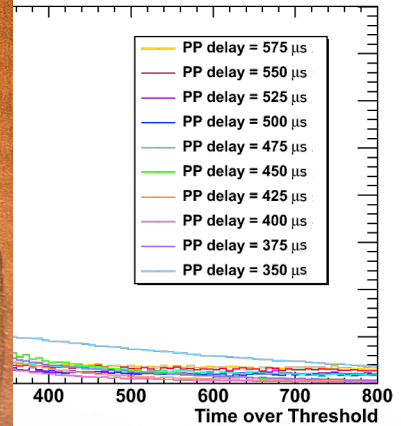
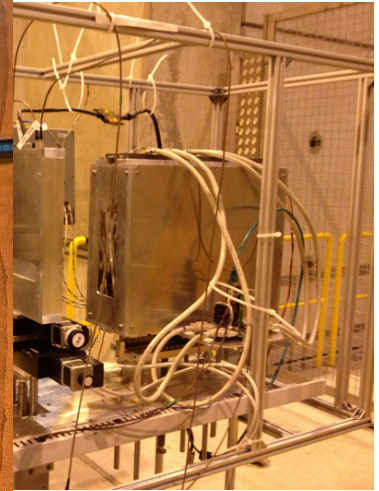
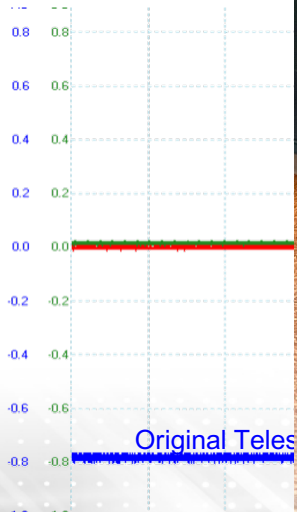
First experimentation with Timepix (2011-2012)

- Initial effort to start the experimental side of R&D focused on Timepix, the ASIC available at the time
- With a scope, an assembly and a source, we demonstrate proof-of-concept of power pulsing the assembly
- We later hook up to the Timepix LHCb telescope to demonstrate that with tracking



First e Timep

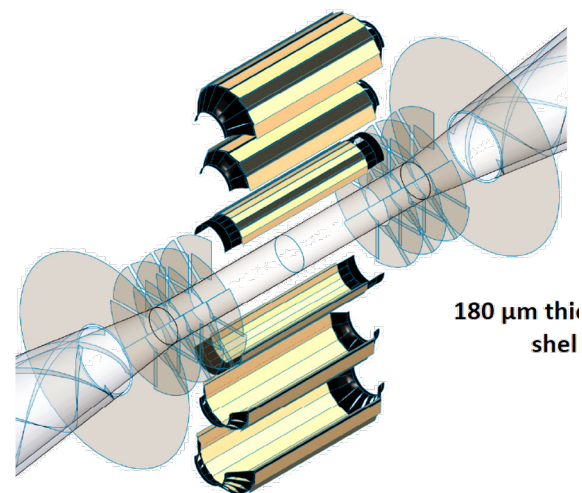
- Initial effort to s
focused on Tim
time
- With a scope, s
demonstrate p
the assembly
- We later hook
to demonstrate



Mechanical and Cooling simulation

From the insight of the CDR, study of mechanical integration of air cooling in the vertex detector were started to evaluate how to evacuate the dissipated energy from the tracking volume

F. Duarte Ramos



Air delivery

Forward tracking disks 1-6 splitted in 45 deg wedges so that air can flow through

45°

Air velocity

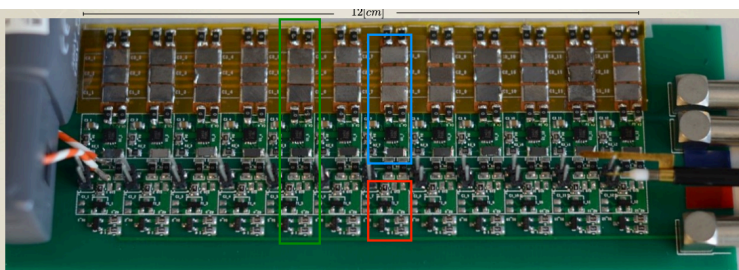
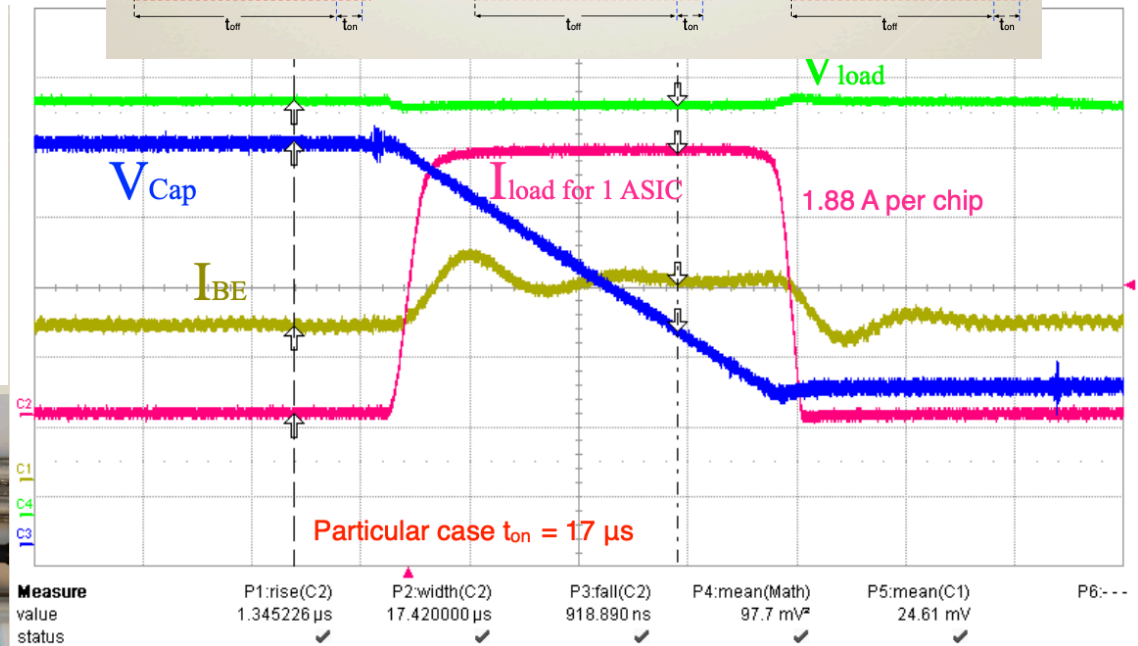
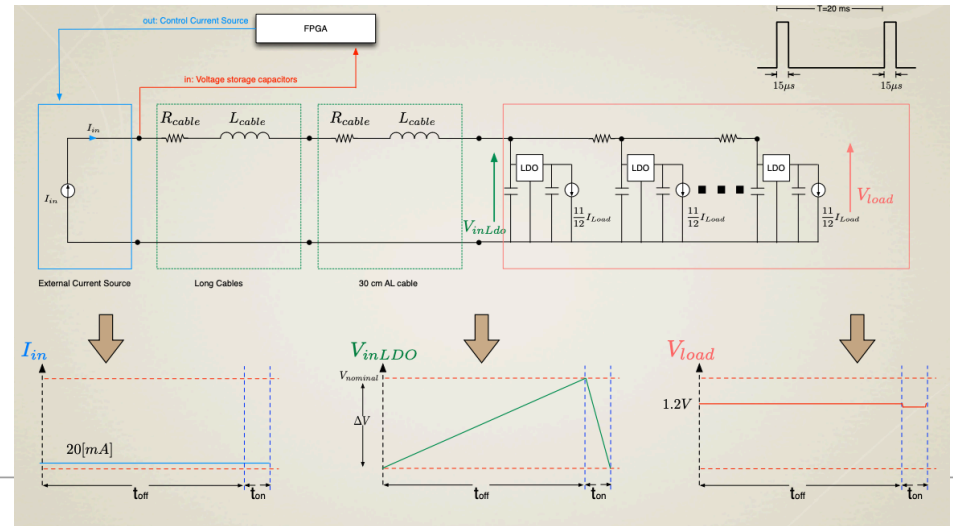
Si temperature

Temperature
Temp Layer 2
45.0
40.5
36.0
31.5
27.0
22.5
18.0
13.5
9.0
4.5
-0.0
(C)

Powering and power pulsing

To deliver pulse power in a pulsed detector floating in a strong magnetic field, a new powering scheme based on LDO and super capacitors was studied to demonstrate the feasibility of our concept

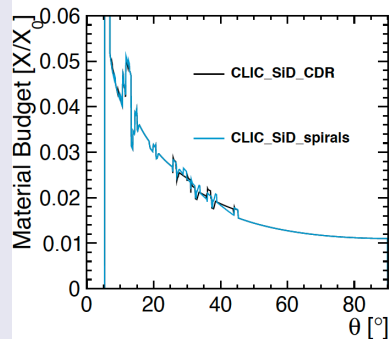
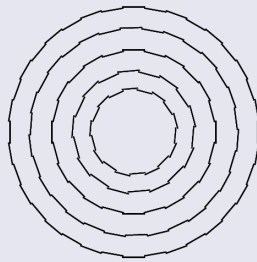
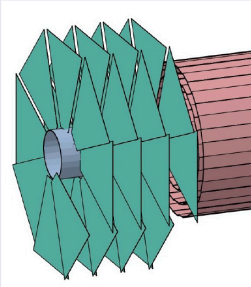
- Local storage of energy required for data acquisition in super-capacitor
- Low steady current in powering line
- Demonstrated in laboratory using dummy load



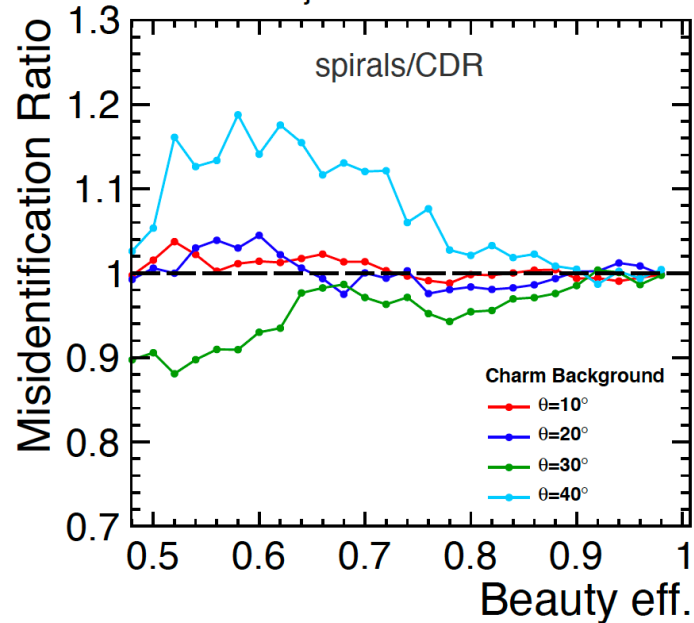
Petals and whirlwinds !

CLIC_SiD_spirals

- Allows airflow cooling with the same barrel as the CDR geometry.



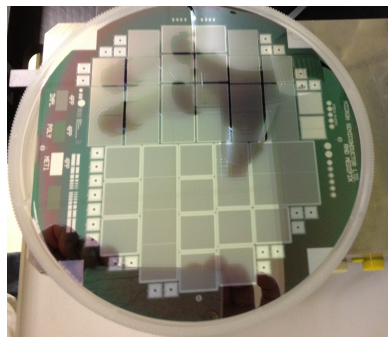
Dijets at 200 GeV



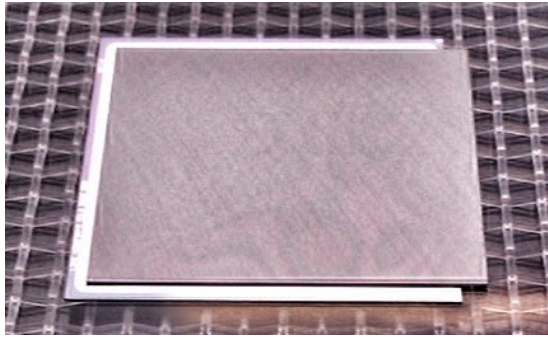
CLIC specific condition lead to the modification of existing detectors and optimize them. This was first steps towards a detector model specific to CLIC

First pixel sensor prototypes : Timepix sensors

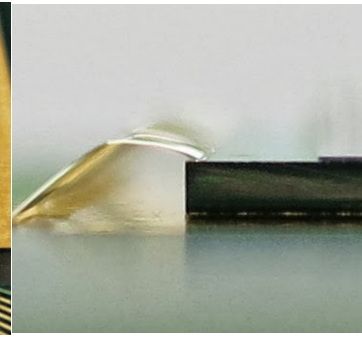
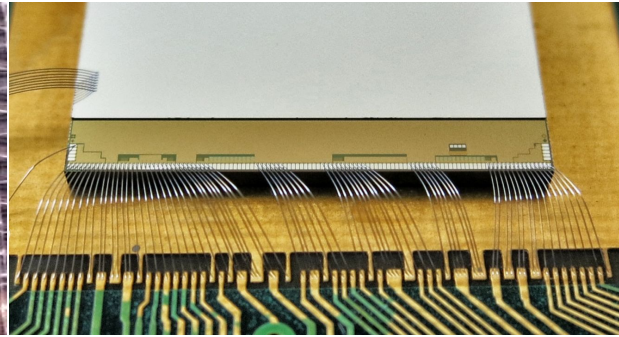
100 um thick Sensor
wafer



100um ASIC -on-100um Sensor
functional Timepix assembly

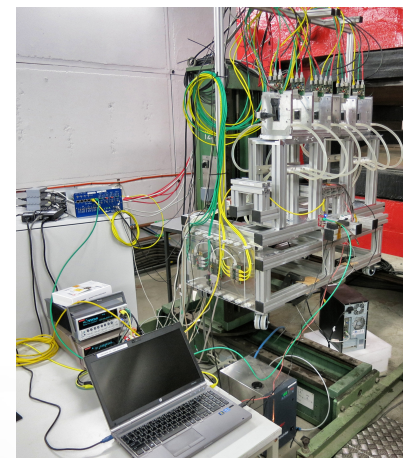


50um Sensor on 750um ASIC functional Timepix assembly



Thin Planar sensors were one of the goals of the Vertex detector R&D. Our efforts lead to the production of very thin assemblies with sensors from Advacam, Micron Semiconductor with sensor thickness down to 50 um

We produced the first 100um on 100um Timepix assemblies, a record at the time ! We then extensively characterize the sensors at DESY using the EUDET Telescope



Test beam !!

Thickness: 50 μm

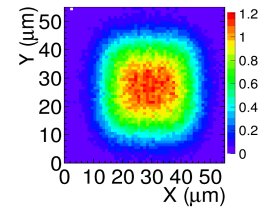
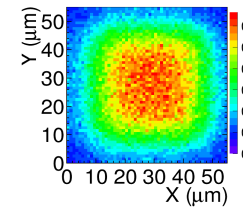
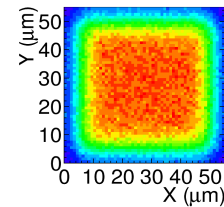
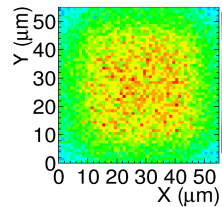
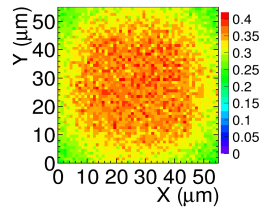
100 μm

150 μm

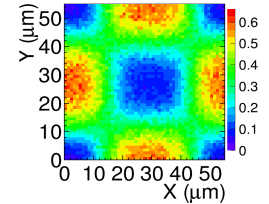
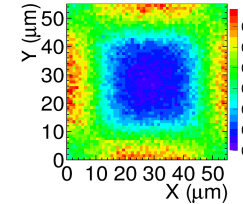
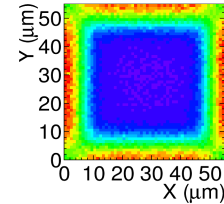
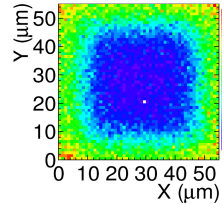
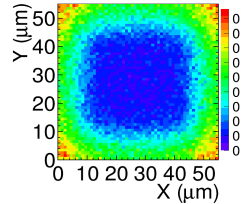
200 μm

500 μm

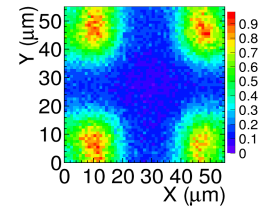
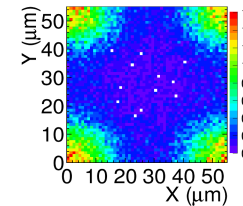
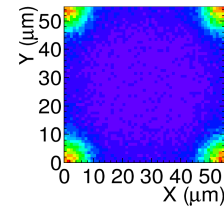
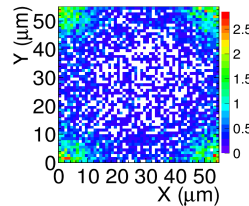
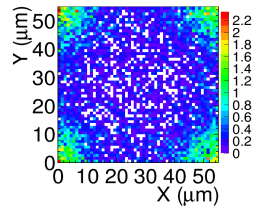
Cluster size 1



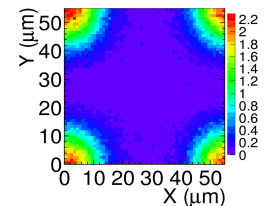
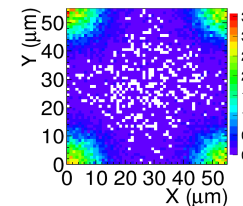
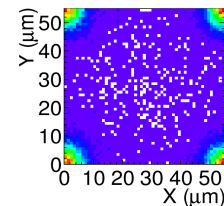
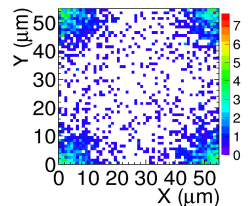
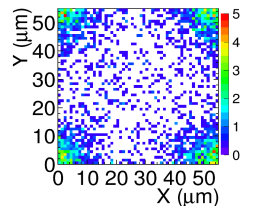
Cluster size 2



Cluster size 3



Cluster size 4



A newcomer ...

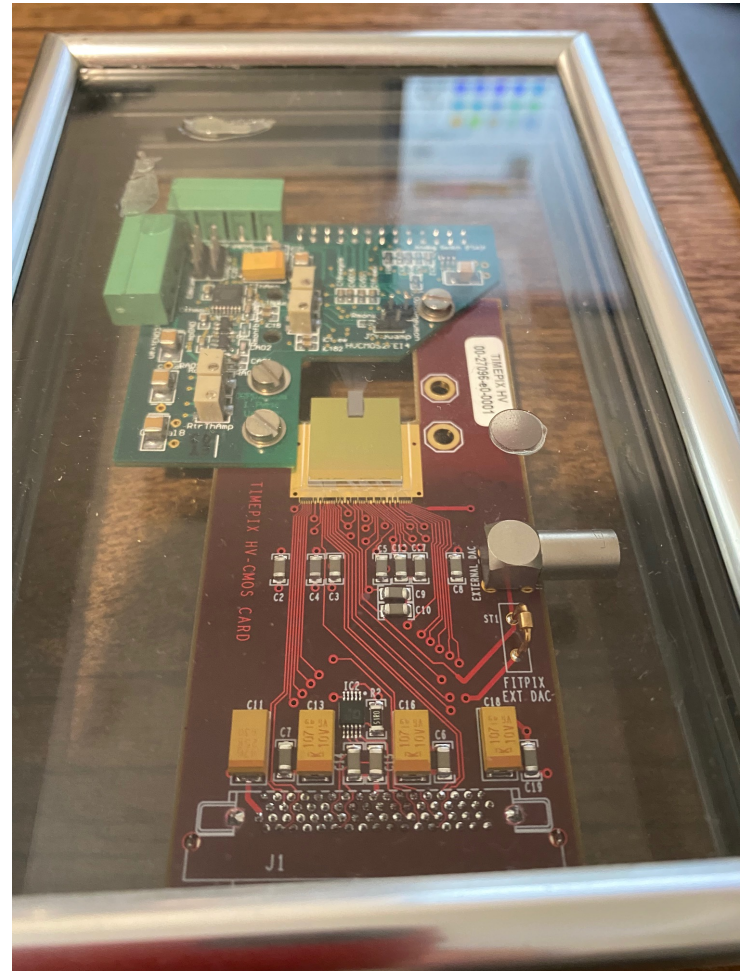
Meanwhile... A certain I. Peric in Mannheim was playing with a new kind of sensor called **CCPD in HV-CMOS technology**. He agreed to add 1 row of pixels matching Timepix footprint on the CCPDv2 prototype

After designing a custom board, we had one assembly glued ...

It was connected , and we could see the pixels firing when we brought the Sr90 source.

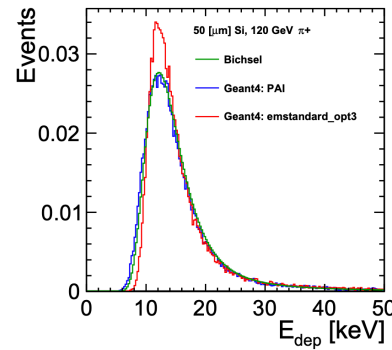
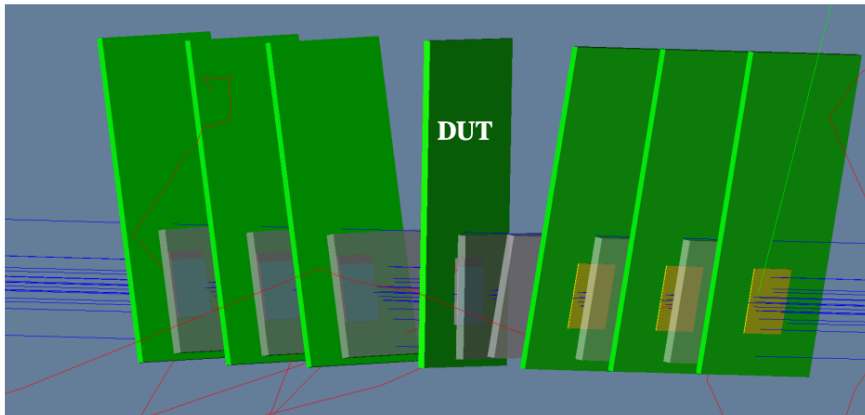
We took a video and went for coffee...

The sample never worked again. It is nice nicely displayed on my office desk ☺

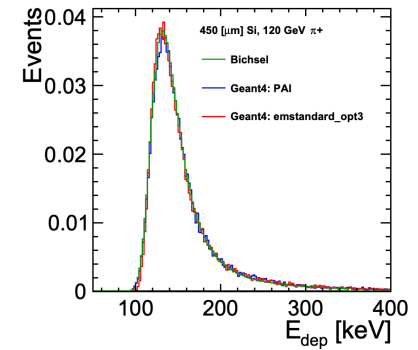


Simulation studies

- After a successful first round of production of thin sensor prototype, with large amount of data on disk, A lot of work was done on optimizing simulation models using Allpix and TCAD simulation to project performance to smaller pixels



(a)



(b)

Figure 5.1: Energy-loss distribution in (a) 50 μm and (b) 450 μm thick silicon sensors due to the passing of 120 GeV pions (π^+) comparing the Bichsel model and GEANT4 using the PAI and the emstandard_opt3 physics lists.

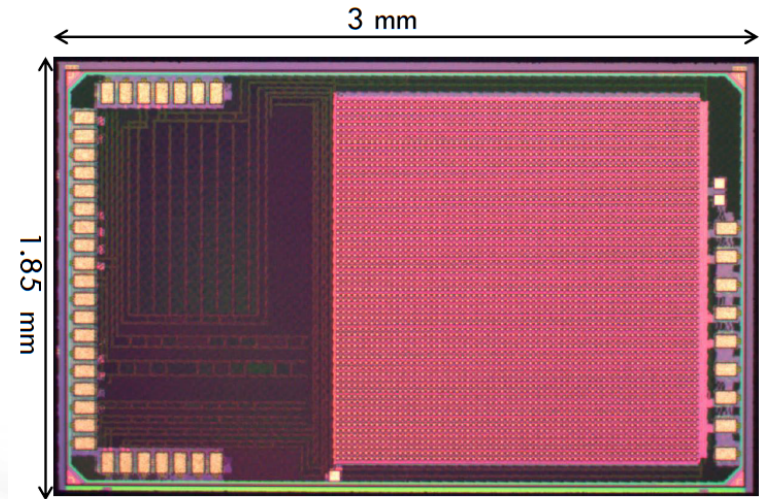
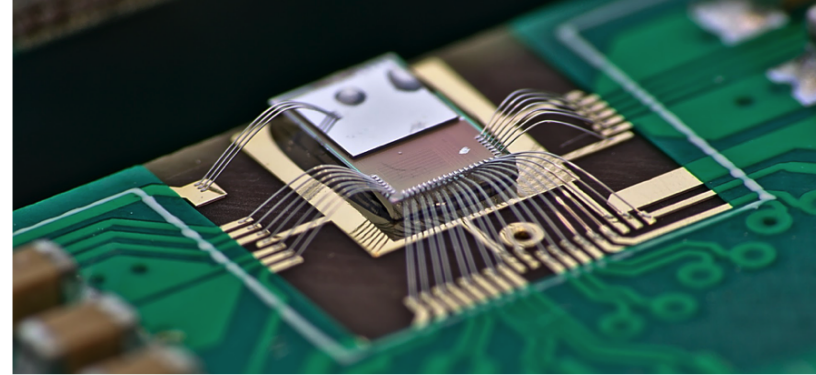
ASIC Development : CLICpix

Main features:

- Small pixel pitch (**25 μm**),
- **Simultaneous TOA** (4 bits) & **TOT** (4 bits) measurements
- **100MHz measurement clock** and 320 MHz readout clock
- **Power pulsing**
- **Data compression**
- Both pulse polarities can be handled

Demonstrator CHIP:

- commercial **65 nm CMOS technology**
- **array of 64x64 pixels**
- The **Krummenacher architecture**, with a single ended preamp, a two stage discriminator and a 4-bit DAC



The next generation : Timepix3

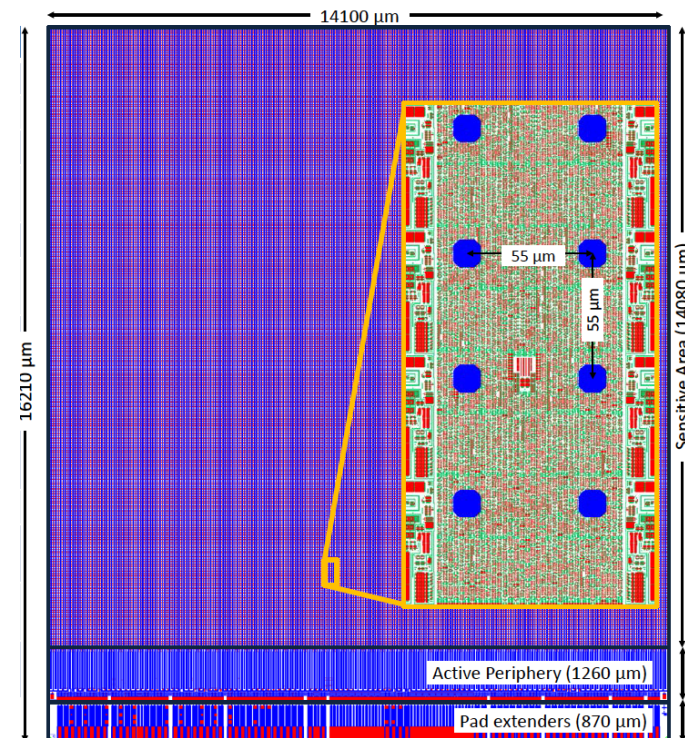
Timepix3 ASIC was received at CERN beginning of 2014. it represents a revolution w.r.t. the previous generation :

- ~10 ms readout time -> Data driven @ 10Gb/s
- TOT or TOA -> TOT(10bits) + TOA
- Proprietary DAQ -> DAQ developed by NIKHEF and CERN, full control of hardware + software

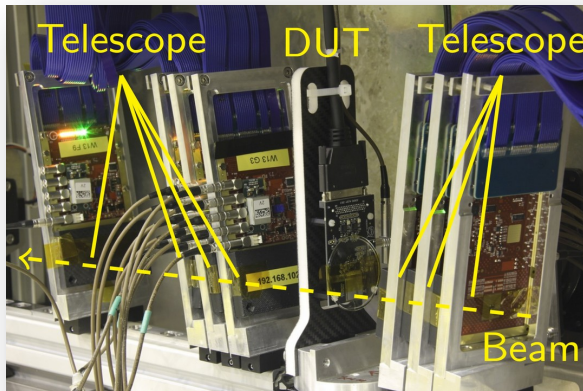
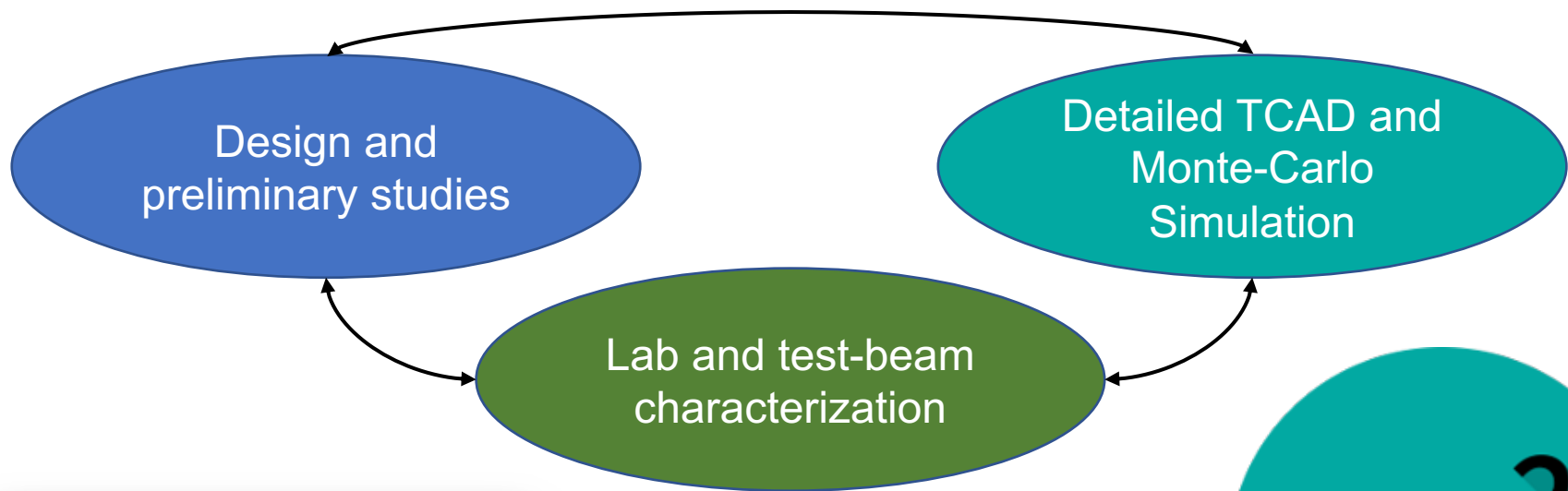
A Multi-Project Wafer common to ATLAS, UNiGe and CLIC to investigate further thin active-edge assemblies was produced with Advacam

15 wafers iproduced: 5x 50um, 5x100um, 5x200um
Timepix3 and CLICpix compatible sensors with 20 and 50um active-edges

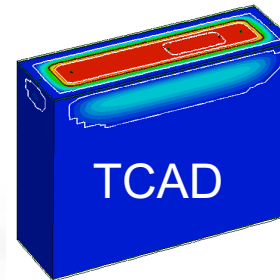
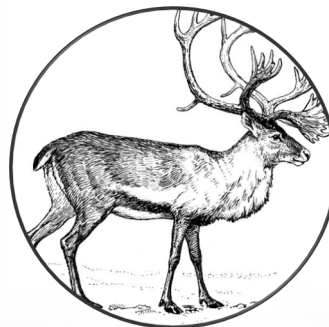
Possibility to flip-chip to 50um thin ASIC with TSV from a parallel project with LETI using Timepix3



Vertex and tracking R&D cycles

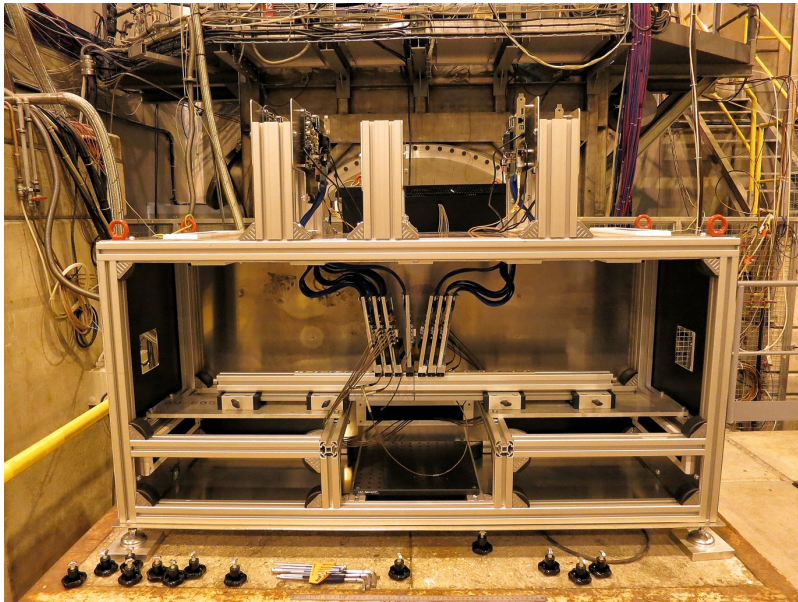


Our toolbox



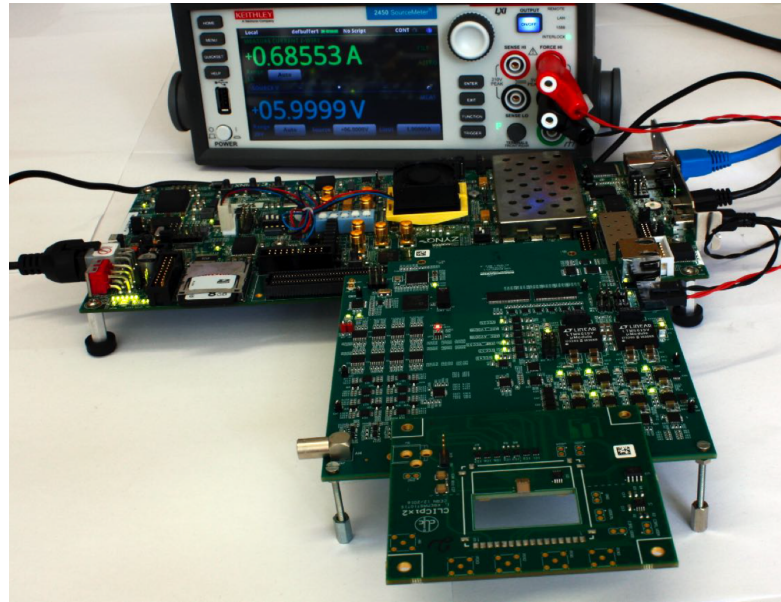
**Timepix3 Telescope @ SPS
and Caribou universal readout**

Tools: The CLICdp Timepix3 Telescope and Caribou readout



The CLICdp Timepix3 telescope

- 7 x Timepix3 telescope planes
- Continuous readout
- ~1.2ns time resolution on tracks
- ~2 μm resolution at the DUT
- Flexible mechanics with rotation stages for angle study



The CaRIBOu universal readout framework

- Multi-chip modular r/o framework
- Stand-alone system based on Zynq SoC running YOCTO Linux
- [Peary generic DAQ software](#)
- [Generic CaR board](#) for powering and monitoring of DUT
- Implementation for CLICPix, CCPDs, ATLASPix, FEI4, H35DEMO and more ...

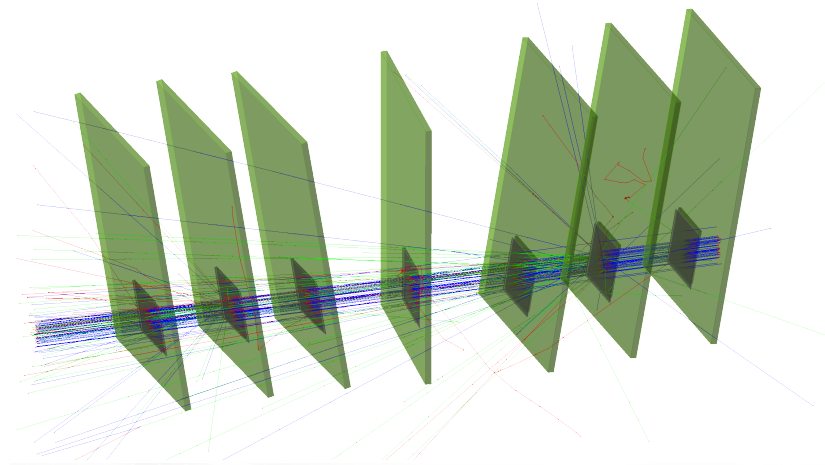
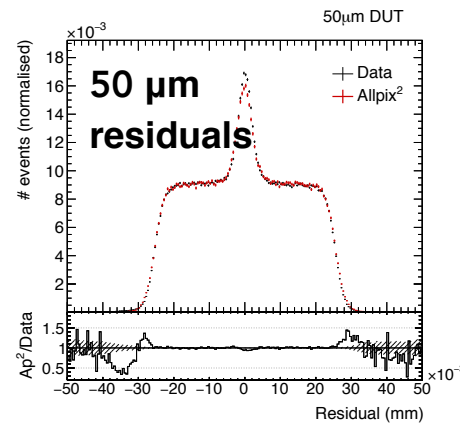
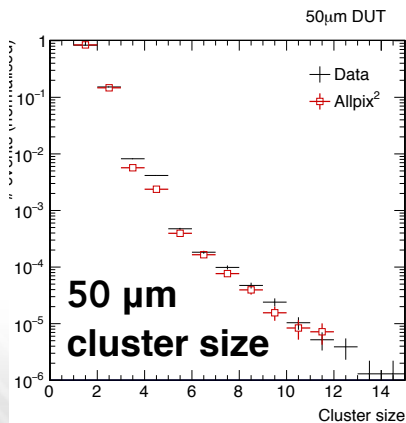
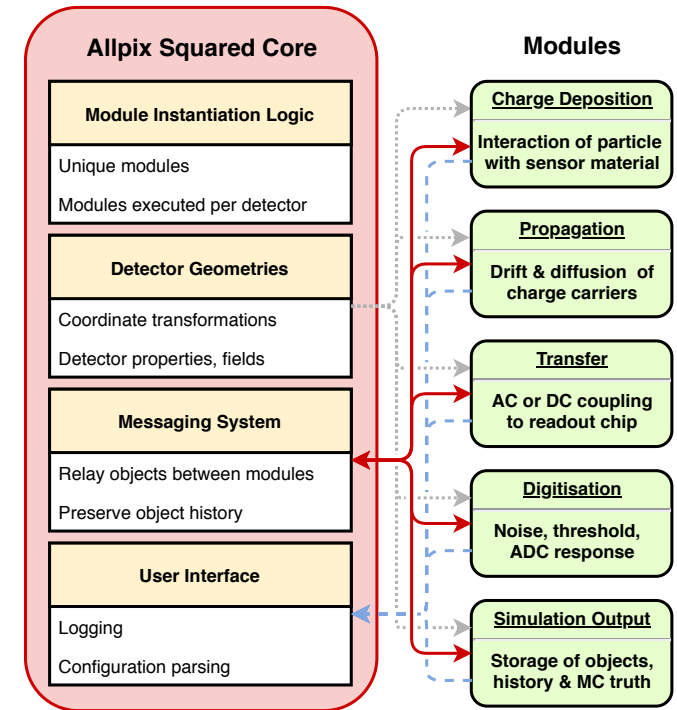
Tools : Allpix²

CERN.CH/allpix-squared



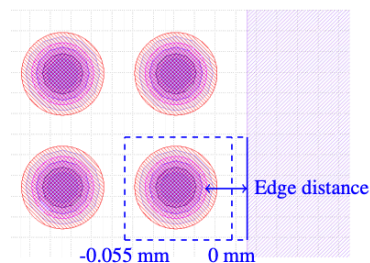
• A **Modular, Generic** Simulation Framework for pixelated Detectors

- Generic simulation of pixel, strip detectors
- Simple text base description of the geometry, simulation parameters
- Charge transport and TCAD Electric Field import facilities
- Visualisation and digitisation
- Output in popular formats (EUDET, PROTEUS, Corryvreckan, etc..)

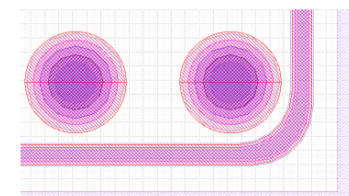


Active-edge planar sensors with Timepix3

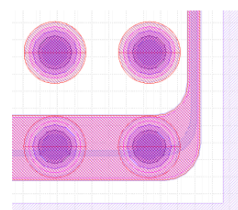
In view of the new sensor production, extensive TCAD simulation studies were also performed to optimize the submitted designs



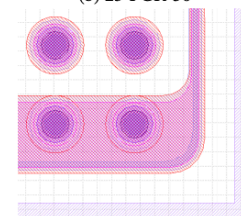
(a) 20-NGR-50



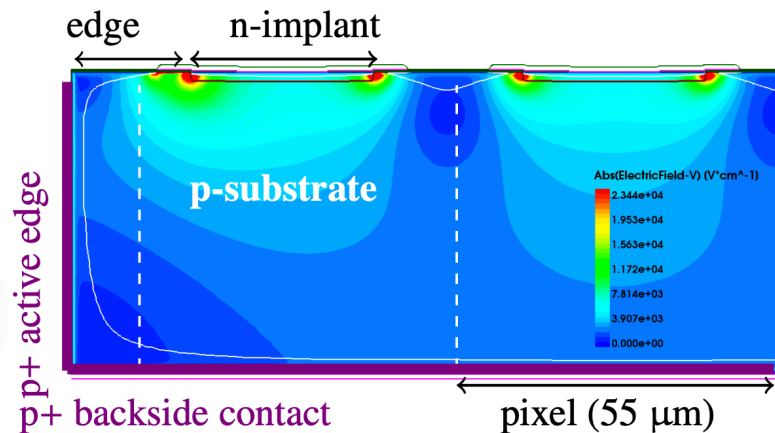
(b) 23-FGR-50



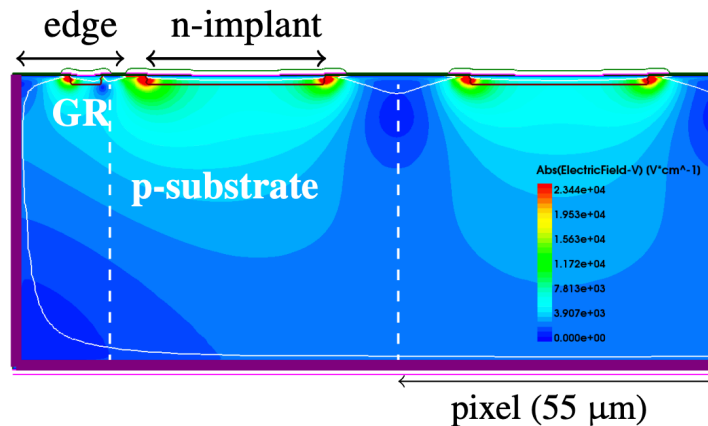
(c) 28-GNDGR-50



(d) 55-GNDGR-50, 55-GNDGR-100, 55-GNDGR-150

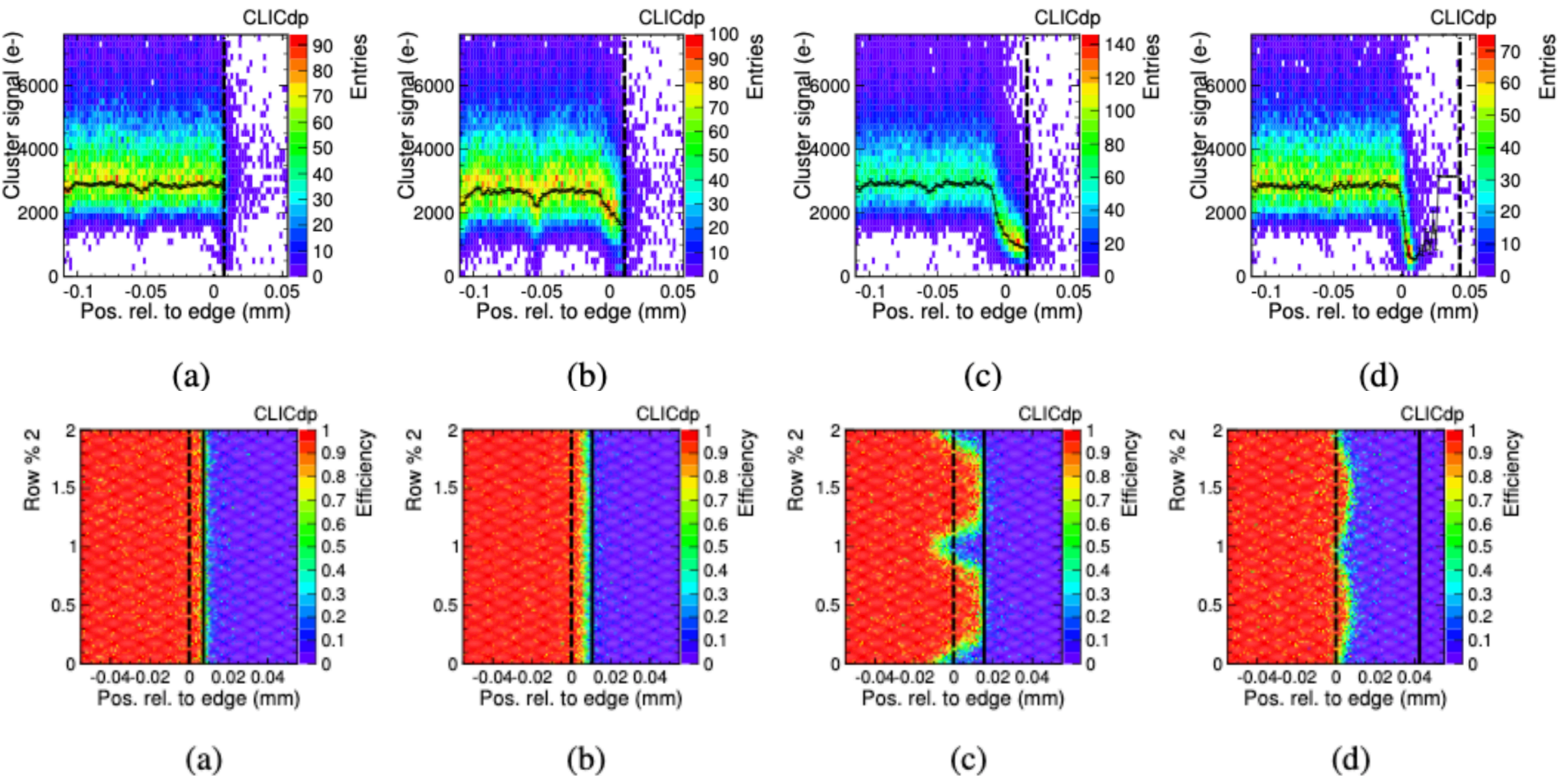


(a) No guard ring



(b) With guard ring

Timepix3 Active-edge measurements



First results with 25 μ m pitch

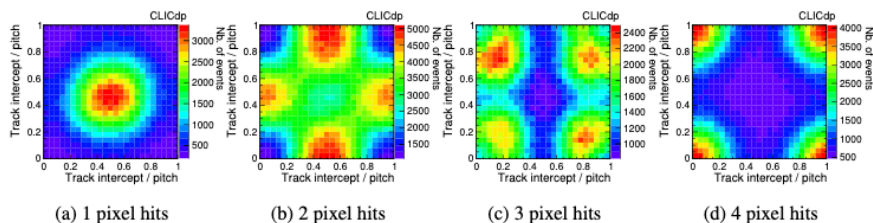


Figure 3.33: Track intercept within the pixel cell of the 200 μ m planar CLICpix assembly for different cluster sizes.

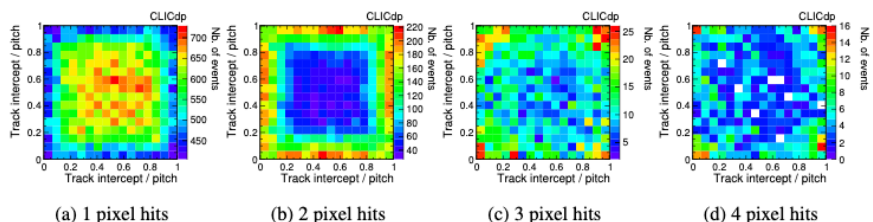
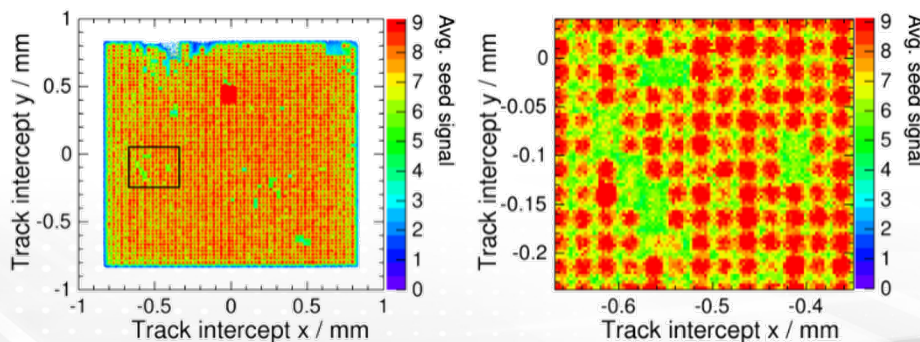
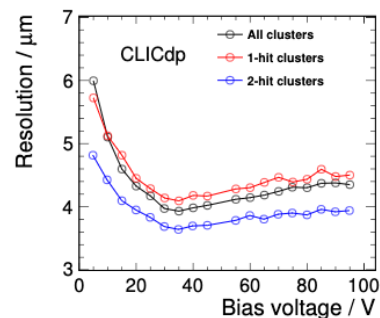
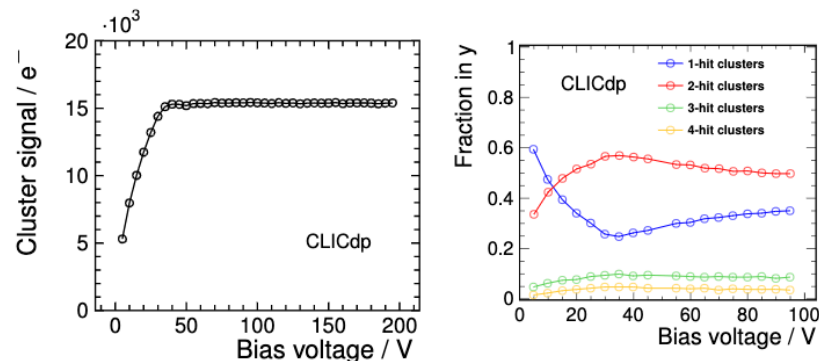


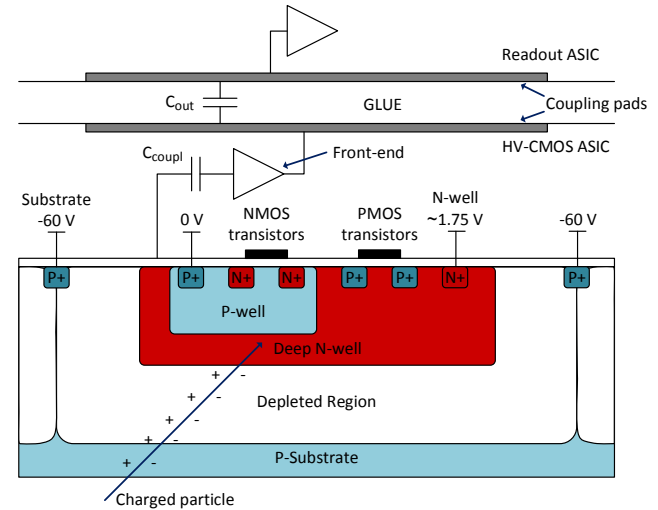
Figure 3.34: Track intercept within the pixel cell of the 50 μ m planar CLICpix assembly for different cluster sizes.



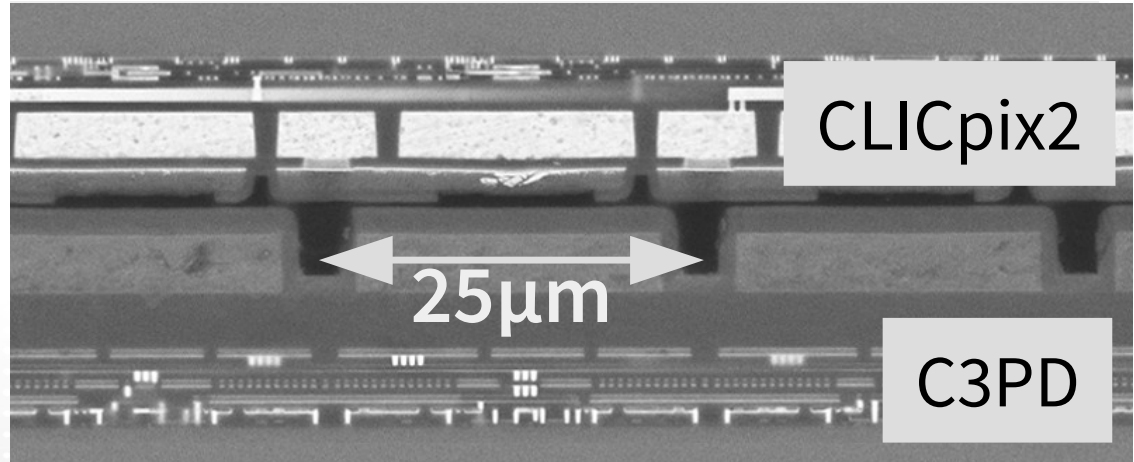
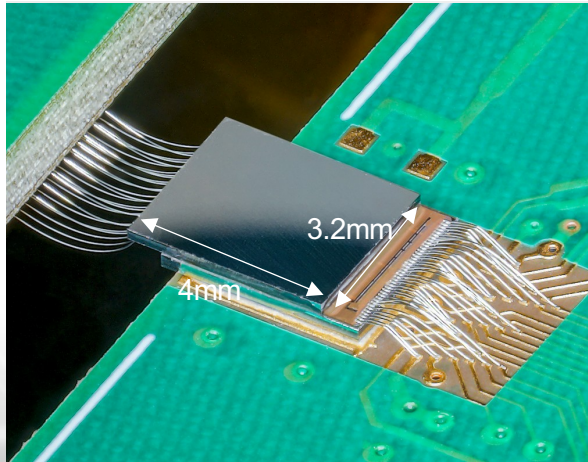
Capacitively-Coupled Pixel Detectors (CCPD)

(CCPDv3)C3PD+CLICPix(1)2

- 2 sensors, CCPDv3 and CLIC CCPD (C3PD) were designed in ams aH18 HV-CMOS technology
 - (64x64) 128x128, 25x25 μm^2 pixels
 - Substrate resistivity from **20 to 200 Ωcm**
- First **amplification layers integrated in sensors** to provide large signal at output
- **I²C 2-wire slow-control** interface (C3PD)
- Coupling with ASIC done through a **very thin layer of glue** forming a capacitor (Low mass!)
 - Glueing method developed to using **flip-chip** assembly to achieve down to **100 nm glue layers**
 - **Fast prototyping method** wrt planar sensors

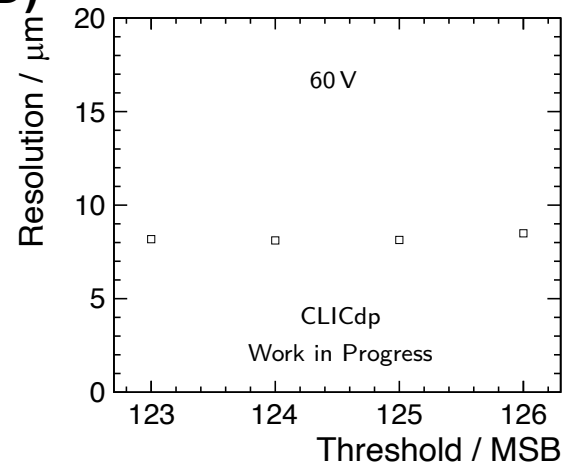
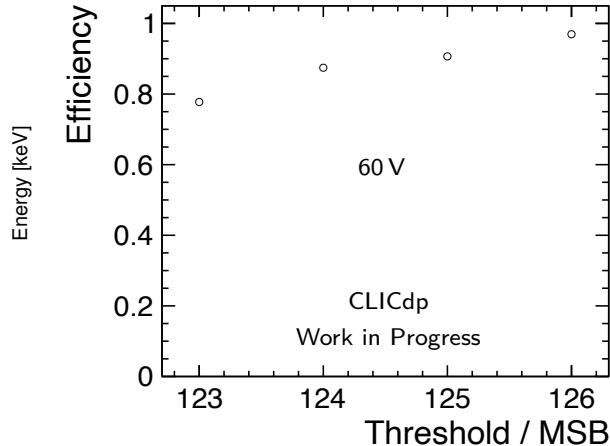
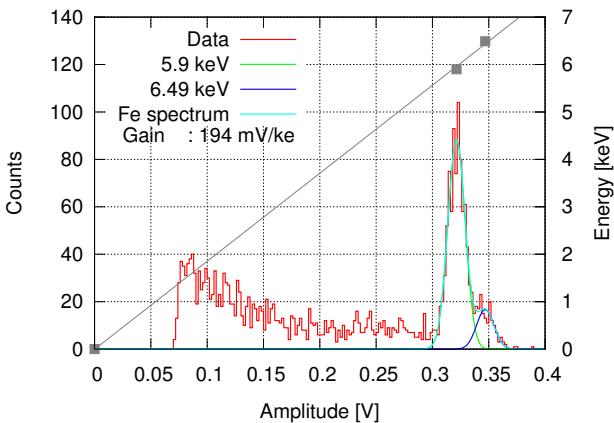


Nucl. Instrum. Methods Phys. Res., A 823 (2016) 1-8
PhD Thesis M. Buckland CERN-THESIS-2018-114
I. Kremastiotis 2017 JINST 12 C12030
M Vicente et al., [CLICdp-Note-2017-003](#)

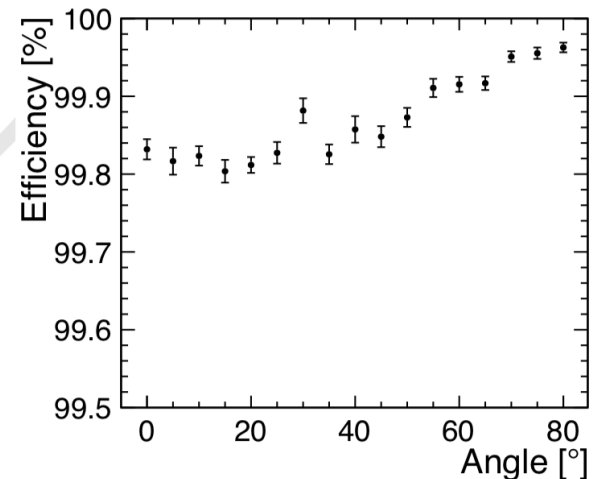
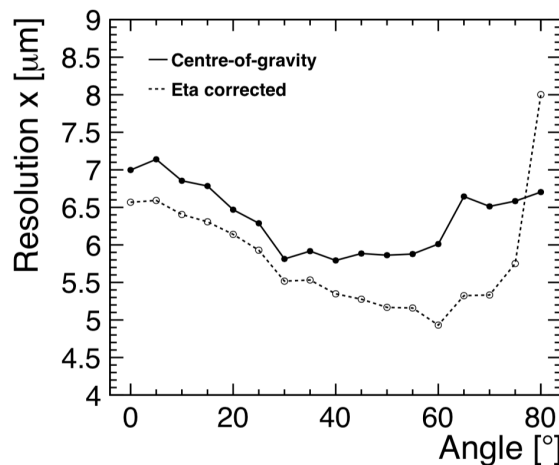
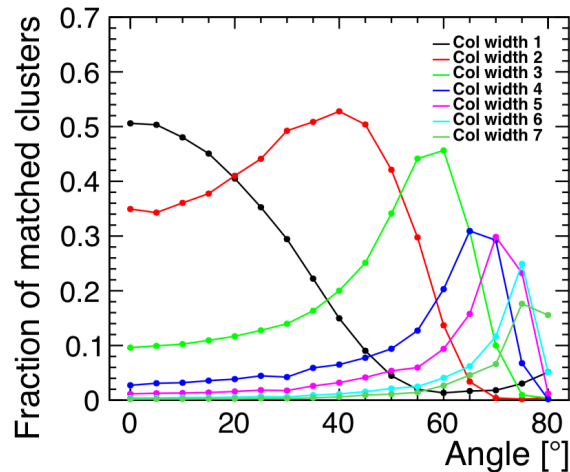


Capacitively-Coupled Pixel Detectors (CCPD)

Tracking performance and energy resolution (C3PD)



Tracking performance versus track angle of incidence (CCPDv3)



Small-Fill factor CMOS sensors

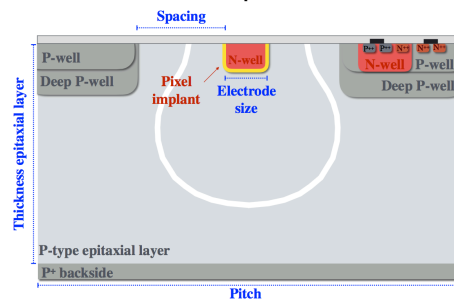
CMOS electronics integrated in **p-well separated from collection electrode**:

- Minimisation of **diode size**
- Minimisation of **sensor capacitance** down to \sim fF (large S/N)
- Process modifications to achieve **full lateral depletion** (W. Snoeys et. al)
- Further modifications proposed to improve timing and radiation hardness, see [Monday presentation by M. Munker](#)

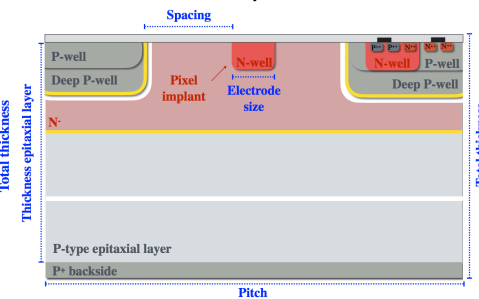
Investigator analogue test-chip:

- Various pixel layouts implemented in different pixel layouts, electrode to pwell spacings

HR CMOS standard process:

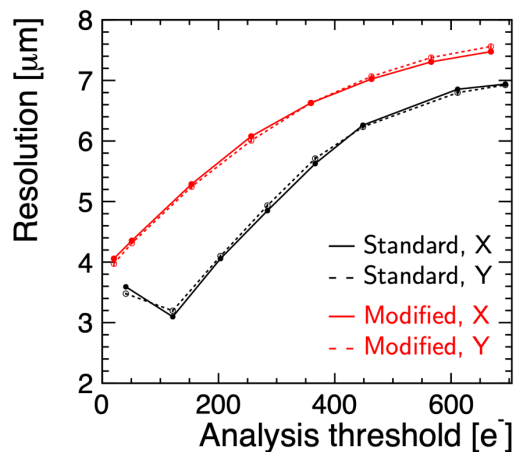


HR CMOS modified process:

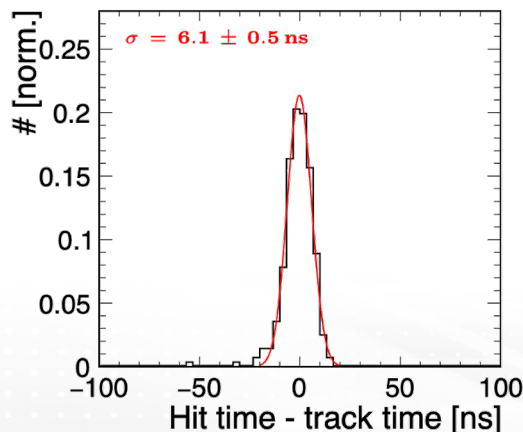


Test-beam results for both process variants:

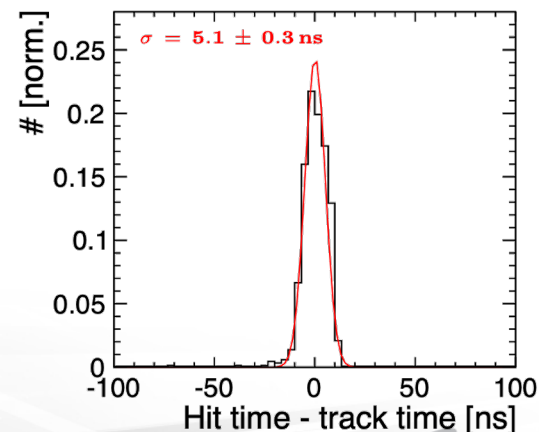
- **Spatial resolution** $\sim 7 \mu\text{m}$ for threshold values of $\sim 400\text{e}$
- **Fully efficient operation** to threshold values below $\sim 400\text{e}$
- **Timing resolution** $\sim 6 \text{ ns}$ (limited by readout)



Standard process:

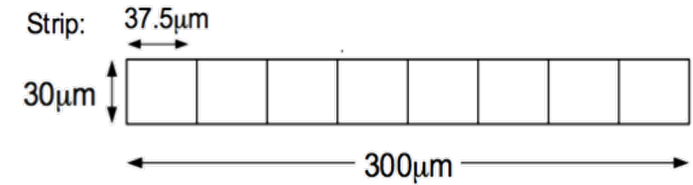


Modified process:



Small-Fill factor CMOS sensors: CLICTD

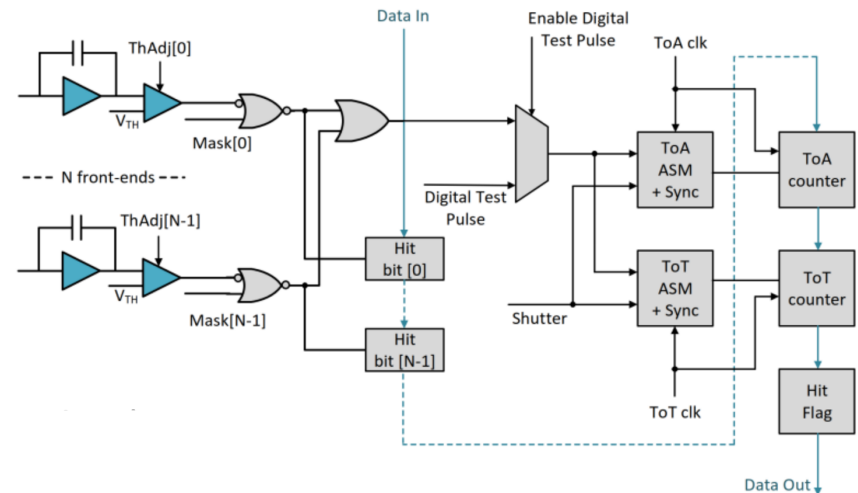
Promising results of 180 nm HR CMOS imaging process trigger design of fully monolithic CLIC tracker chip:



- **Super-pixel segmented in high granular collection diodes** to maintain fast charge collection while reducing digital logic
- Super pixel size of **30 μm x 300 μm**
- Diode size of **30 μm x 37.5 μm**

Diode discriminator outputs combined in 'OR' gate:

- 8-bit ToA and 5-bit ToT measurements
- Storage of **hit-pattern**
- 100 MHz clock for **10 ns time binning**



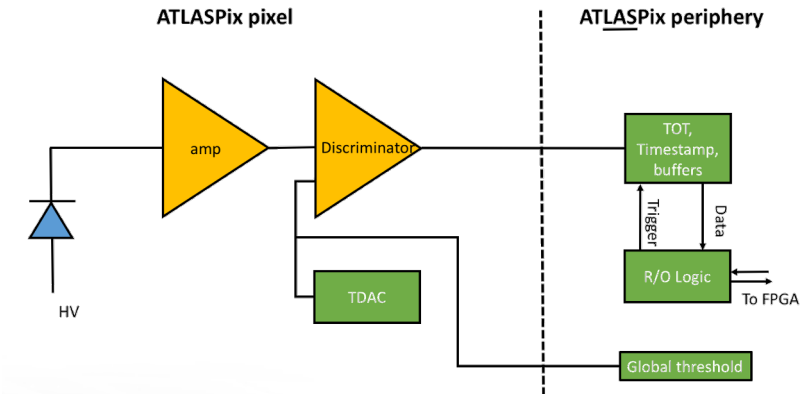
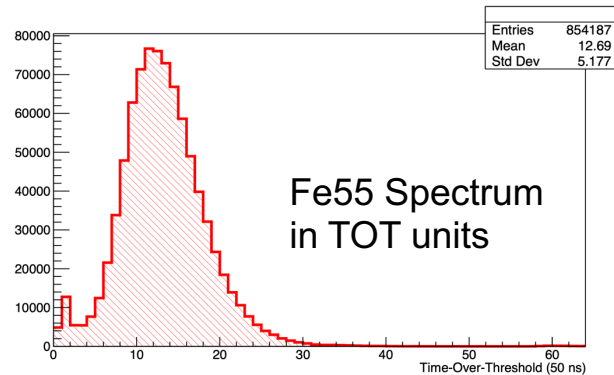
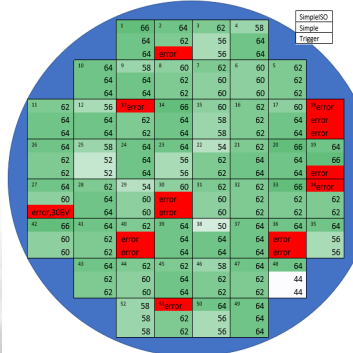
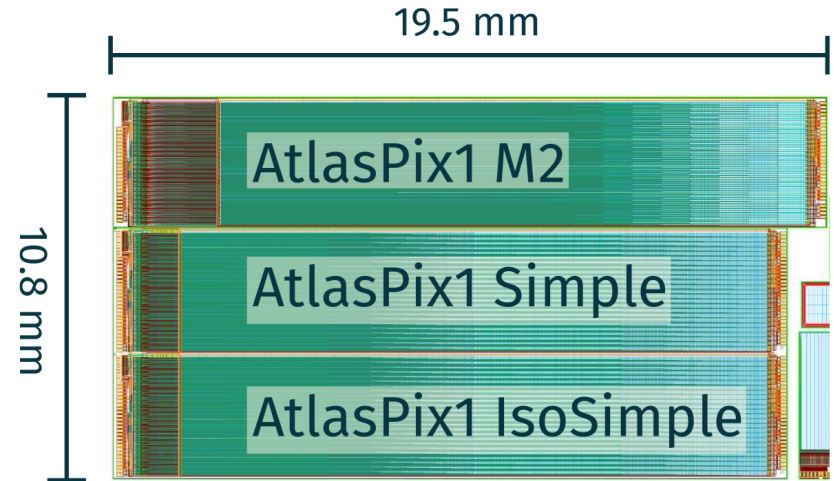
Different operation modes:

- 8 bits time stamping information (ToA) + 5 bits energy information (ToT)
- 13 bits time stamping information (ToA)
- 13 bits photon counting (number hits that are above threshold)

Large Fill-Factor CMOS sensors

Implementation of fully **monolithic** sensors in ams aH18 process using high-resistivity wafers

- **180nm HV-CMOS Engineering** run on **20-200 Ω cm substrate**
- Thinned down to **60 μ m**
- **130x40 μ m² pixels**, 25x400 pixels
- **6 bit TOT** and **10 bit TOA** (up to 16 ns)
- Uniform breakdown across wafers at **60-85V**
- **Threshold** down to **600e**, **120e dispersion**
- **Full length** column sensor (1.9cm)
- **Trigger-less** readout
- Serializer, **PLL**, High-Speed data transmission (**1.25Gbps**, **aurora 8b/10b**)
- Initially design for ATLAS , **Radiation hard up to $>1 \times 10^{15} n_{eq}/cm^2$** , **100MRad**
- **Close to CLIC Requirements**



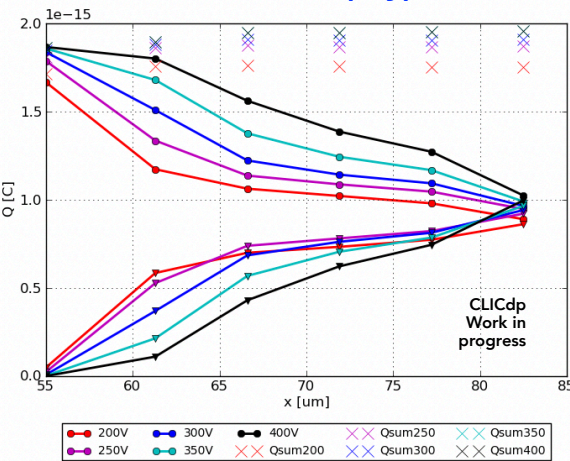
I. Peric et al., A high-voltage pixel sensor for the ATLAS upgrade, Nucl. Instrum. Meth. (2018), in press, DOI: 10.1016/j.nima.2018.06.060.

Enhanced Lateral Drift sensors (ELAD)

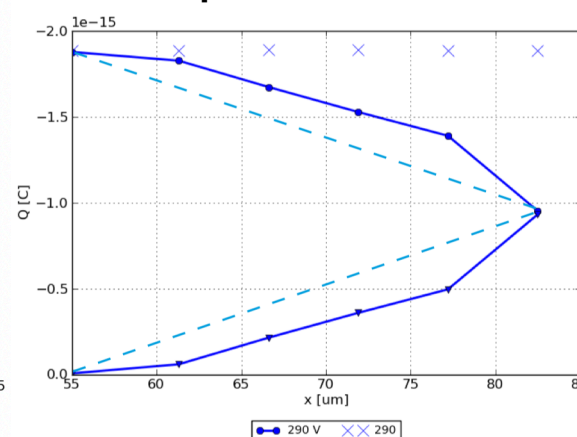
Concept to improve spatial resolution for thin sensors, H. Jansen (DESY/PIER):

- Deep implants to shape electric field lines in sensor
- Suggestive epitaxial layer grow and implantation
- Increased “linearised” charge sharing

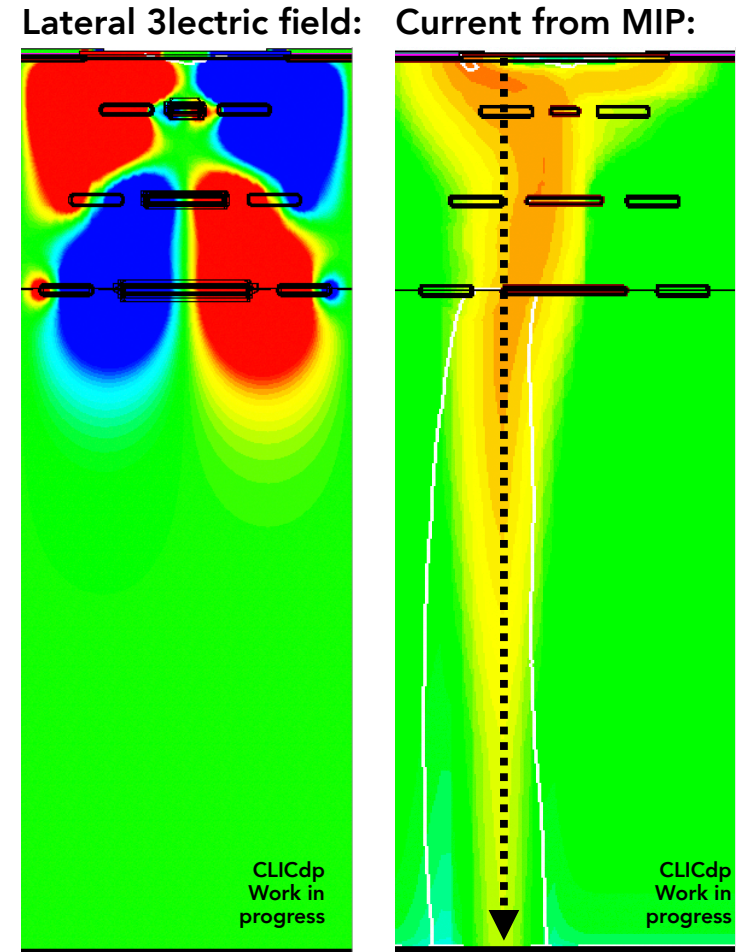
TCAD simulations for p-type ELAD:



Allpix² validation



290V

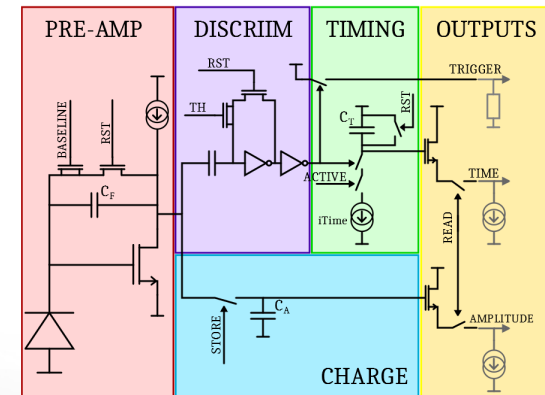
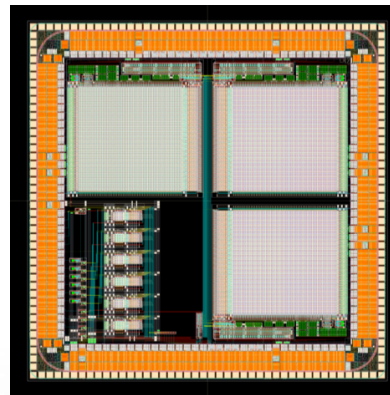
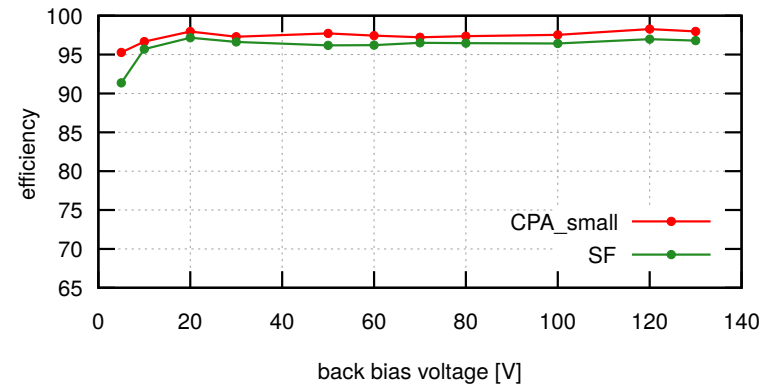
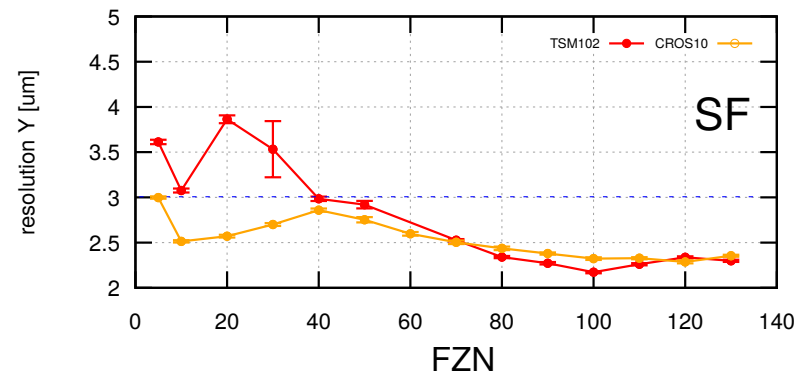


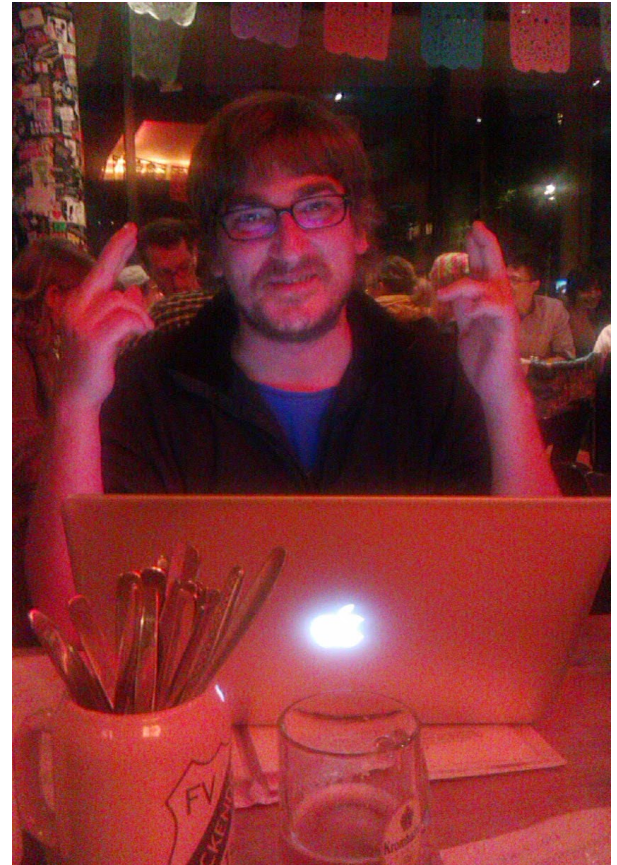
SOI sensors

- **Monolithic integration** with sensor electronics separated from high-resistivity substrate by Oxide layers
- Cracow SOI test chip in **200nm LAPIS SOI process**, different parameters:
 - $\geq 30 \times 30 \mu\text{m}^2$ pixels
 - single-SOI and double-SOI wafers
 - different readout schemes implemented
- First test beam results for 500 μm thickness
 - SOI HR-CMOS: $30 \times 30 \mu\text{m}^2$ pitch, **Efficiency** > 97%, $\sigma_{\text{SP}} = 2 \mu\text{m}$

CLIPS : CLICPixel SOI in production

- $4.4 \times 4.4 \text{ mm}$ (previous 2.9 mm)
- Targets
 - spatial resolution < 3 μm
 - time resolution < 10 ns
- Analog charge and time information in **storage capacitors in each pixel**
--> **no need for fast clock distribution** into matrix
- Snapshot analog **readout between bunch trains** with external ADC
- Timing reference base on **tuned current source**





A lot of great collaborators!

Conclusion

- Work for the CLICdp vertex and tracking R&D over the last 10 years has been tremendous, thanks to the work of our brilliant collaborators
- Collaboration with Medipix/Timepix Collaboration has been key to achieve our objectives
 - Timepix studies
 - Timepix3 Telescope
 - CLICpix, CLICpix2, C3PD, CLICTD
- Tools developed by the collaboration will be used for many more years
 - Allpix2, CaRIBOu and Peary, Coryveckran etc ...
- I want to thank everyone involved for such a great work and for your company over the last 10 years